



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

-----ooo:0:ooo-----

Application of :  
Masatoshi YASUTAKE et al. :  
Serial No. 10/775,724 : Group Art Unit - 2823  
Filed: February 10, 2004 : Examiner- Quovaunda Jefferson  
For: PREPARATION OF SAMPLE :  
CHIP, METHOD OF OBSERVING :  
WALL SURFACE THEREOF AND :  
SYSTEM THEREFOR : Docket No. S005-5210

-----ooo:0:ooo-----

Mail Stop AF  
COMMISSIONER FOR PATENTS  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT AFTER FINAL  
UNDER RULE 116**

S I R:

In response to the Office Action dated June 29,  
2006, applicants request reconsideration of their application  
as follows:

**ADDITIONAL FEES:**

No additional fees are believed required in  
connection with this amendment; however, should it be  
determined that a fee is due, authorization is hereby given to  
charge any such fee to our Deposit Account No. 01-0268.

**MAILING CERTIFICATE ON PAGE 17**

Please Enter  
12/14/2006  
QJ